

Docket No.: 071971-0569



**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080  
Akio MISAKA : Confirmation Number: 7423  
Application No.: 10/576,120 : Group Art Unit: 1795  
Filed: April 18, 2006 : Examiner: Rashid A Alam  
For: PHOTOMASK AND PATTERN FORMATION METHOD AND MASK DATA GENERATION METHOD USING THE SAME

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☒ Also attached: RCE Transmittal

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	19	31	0	\$52.00 =	\$0.00
Independent Claims	1	4	0	\$220.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
RCE					\$810.00
Total of Above Calculations					\$810.00

- ☒ Please charge my Deposit Account No. 500417 in the amount of \$810.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: August 19, 2010

Please recognize our Customer No. 53080 as our correspondence address.